## 501.41175X00/340101349US1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hiroyuki NAKANO et al.

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15 February 2002

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METHOD AND APPARATUS FOR PLASMA PROCESSING

Group:

1762

Examiner:

M. Padgett

Conf. No.:

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## **NOTICE OF APPEAL**

Mail Stop AF
EXPEDITED PROCESSING REQUESTED UNDER 37 CFR §1.116
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

18 April 2005

Sir:

Applicant respectfully appeals the decision of the Examiner in finally rejecting Claims 1-18 (Claims 19-35 are pending but withdrawn from consideration) in the Office Action mailed 18 November 2004 in connection with the above-identified application. A PTO-2038 authorizing payment of all fees required for entry of this paper is being filed concurrently herewith. Please charge any actual fee deficiency to ATS&K Deposit Account No. 01-2135 (as Case No. 501.41175X00).

Respectfully submitted,

04/20/2005 RECNHER 00000017 10075244

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500.00 OP

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